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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## Response Under 37 C.F.R. § 1.116 Expedited Procedure

In re application of: Agarwal et al.

Application No. 10/002,779

Filed: October 29, 2001

Confirmation No. 6254

For: METHODS FOR FORMING AND  
INTEGRATED CIRCUIT STRUCTURES  
CONTAINING RUTHENIUM AND  
TUNGSTEN CONTAINING LAYERS

Examiner: David Vu

Art Unit: 2818

Attorney Reference No. 6047-61466-01

MAIL STOP AF  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: MAIL STOP AF, COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450 on the date shown below.

Attorney  
for Applicant(s)

Date Mailed August 4, 2004TRANSMITTAL LETTER

Enclosed is an Amendment after Final Action for the above application. The fee has been calculated as shown below.

CLAIMS AS AMENDED					
For	No. after amendment	No. paid for previously	Present Extra	Rate	Fee
Total Claims	13	- 20*	= 0	\$18.00	\$ 0.00
Indep. Claims	5	7**	= 0	\$86.00	\$ 0.00
Mult. Dep. Claims Fee (if not previously paid)					\$290.00
One-month Extension of Time					\$110.00
Two-month Extension of Time					\$420.00
Three-month Extension of Time					\$950.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

\* greater of twenty or number for which fee has been paid.

\*\* greater of three or number for which fee has been paid.

- No additional fee is required.
- Please charge any additional fees that may be required in connection with filing this Amendment after Final Action and any extension of time to Deposit Account No. 02-4550. A copy of this sheet is enclosed.
- Please return the enclosed postcard to confirm that the items listed above have been received.

Respectfully submitted,

KLARQUIST SPARKMAN, LLP

By



\_\_\_\_\_  
Michael D. Jones  
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**AMENDMENT AFTER FINAL ACTION**

This responds to the Office action dated July 22, 2004. Please amend the referenced application as follows:

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2.

**Remarks** begin on page 5.